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10002177
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PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10002177	FILING DATE 12/05/2001	CLASS 429	SUBCLASS 730	GAU 473243	EXAMINER Kackar
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**APPLICANTS: Komeno Junji; Shiina Kazushige;

**CONTINUING DATA VERIFIED:

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** FOREIGN APPLICATIONS VERIFIED:

JAPAN 2000-373278 12/07/2000

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>	
Foreign priority claimed 35 USC 119 conditions met Verified and Acknowledged Examiner's initials		<input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> yes <input type="checkbox"/> no	ATTORNEY DOCKET NO Q67579
TITLE : Film-forming device with a substrate rotating mechanism			
U.S. DEPT. OF COMM /PAT & TM-PTO-436L (Rev. 12-94)			

NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED	
			Total Claims	Print Claim for O.G
ISSUE FEE		DRAWING		
Amount Due	Date Paid	Sheets Drwg.		Figs.Drwg.
TERMINAL DISCLAIMER		Print Fig.		
		Primary Examiner		
		PREPARED FOR ISSUE		
		Application Examiner		
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